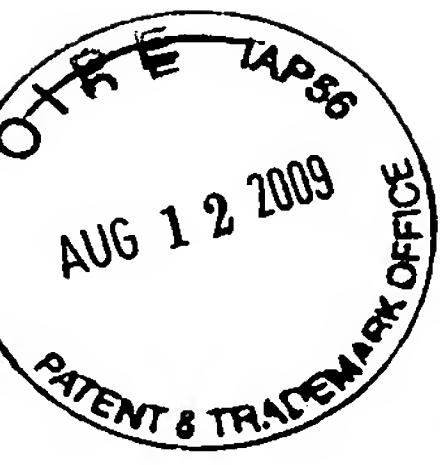


U.S. Serial No.: 10/569,838
Docket No.: F06-436-US
FUJIT.081



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re patent application of

Mineo HIRAMATSU, et al.

Serial No.: 10/569,838 Group Art Unit: 1792
Filed: December 1, 2006 Examiner: LOUIE, MANDY C
For: METHOD FOR PRODUCING CARBON NANOWALLS, CARBON NANOWALLS, AND APPARATUS FOR PRODUCING CARBON NANOWALLS

Honorable Commissioner of Patents
Alexandria, Virginia 22313-1450

**RESPONSE TO FIRST OFFICE ACTION AND
RESTRICTION REQUIREMENT**

Sir:

In response to the Office Action dated July 30, 2009, please consider the following:

INTRODUCTORY COMMENTS

Remarks begin on page 2 of this paper.